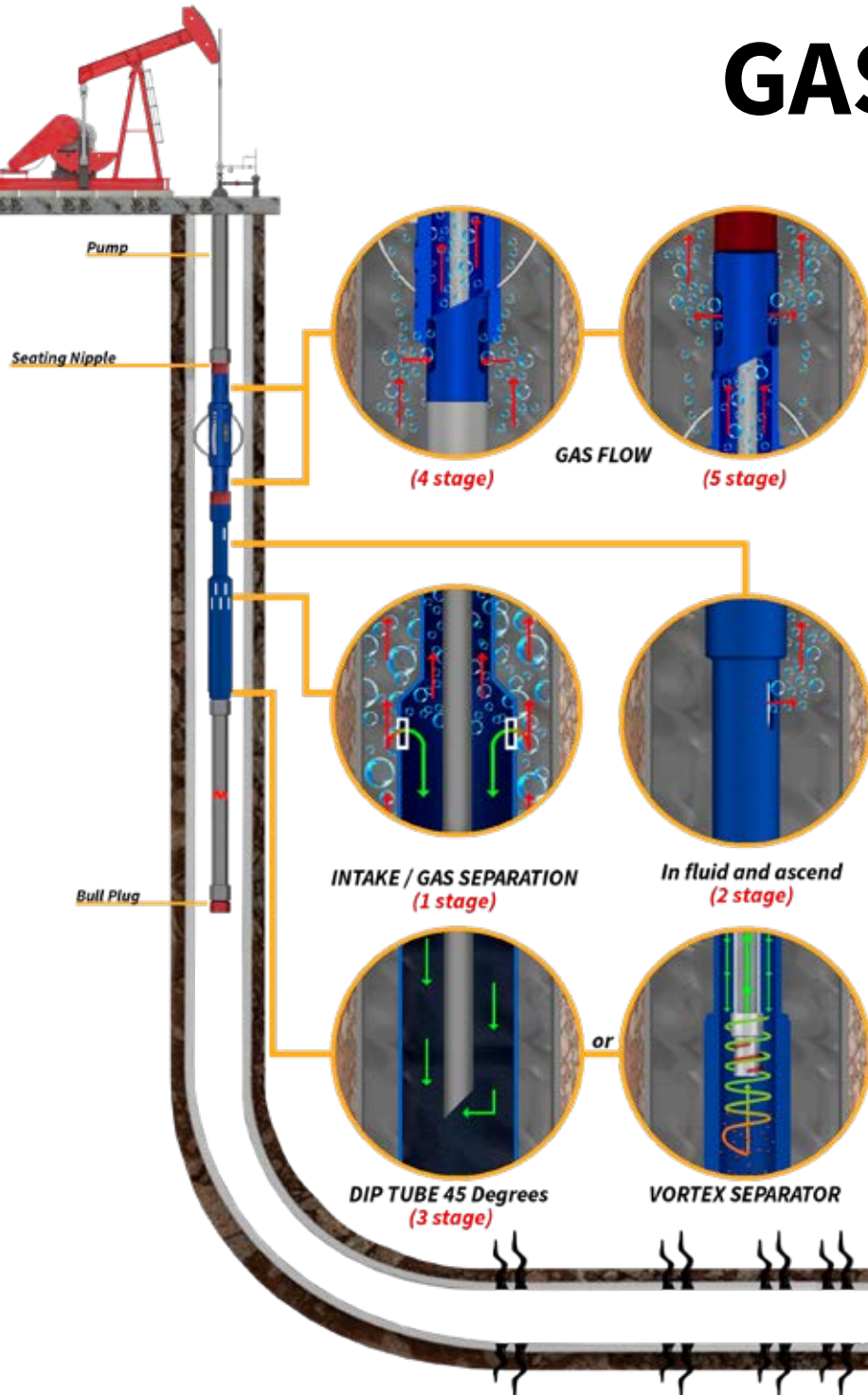


GAS VENT TAC



Gas accumulation around the TAC can result in gas interference and gas locking the subsurface pump.

These problems negatively affect the operating efficiency of the pumping system and can result in long-term damage to the pumping system components.

One of the areas where gas accumulation can be particularly troublesome is around the TAC.

Odessa Separator, Inc. has developed a TAC with a gas vent that prevents gas accumulation below the TAC while providing an effective tubing anchor. Available in both standard and "slim-line" TAC's, the OSI Gas Vent TAC increases annular flow area by 250% and 35% respectively.

Employing patented OSI "Dual-Flow" technology, the Gas Vent TAC can be combined with any gas separator and any other OSI fluid conditioning tools.

Use your device by scanning the QR code

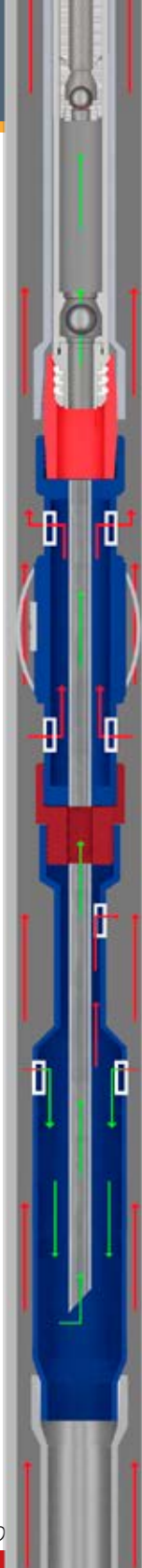


VIDEO

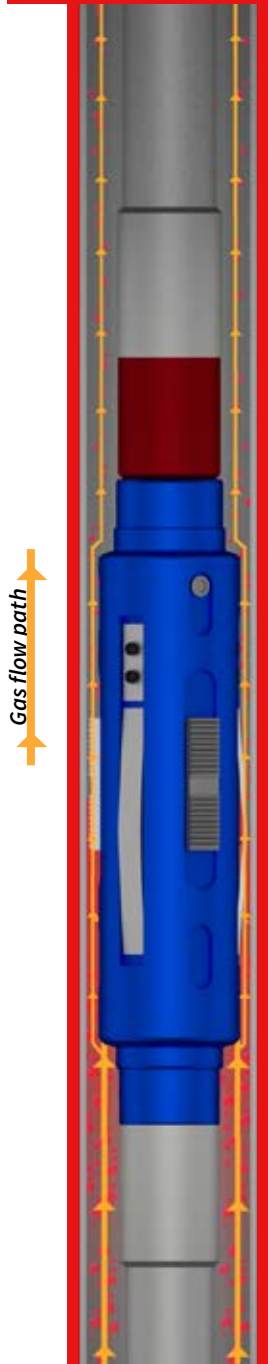


AUGMENTED REALITY

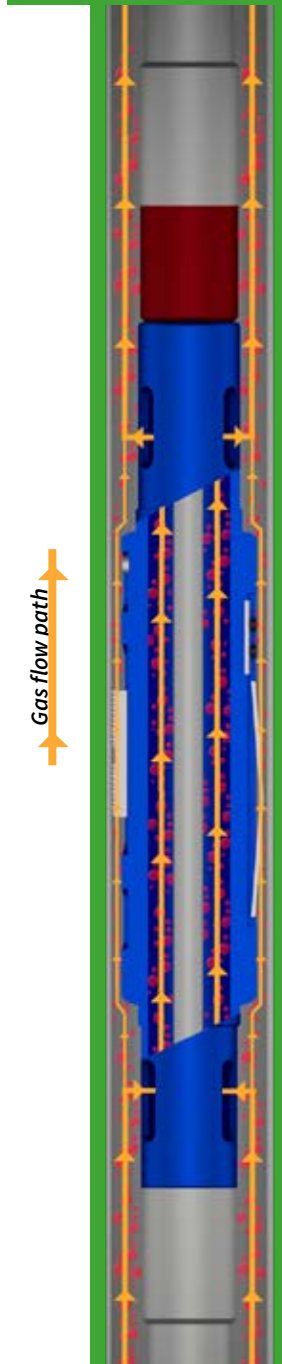
HOW IT WORKS



TRADITIONAL TAC



GAS VENT TAC



- *Maximizes fluid flow area to prevent gas pocket build-up around the TAC.*
- *Increases annular flow area by more than 250% in standard TAC's and more than 35% in slim hole TAC's.*
- *The patented dual flow design allows the gas vent to be combined with any type of gas separator.*
- *The Gas Vent TAC design allows an effective anchor while maximizing fluid flow.*